PAGE 1/43 \* RCVD AT 6/14/2004 3:02:32 PM [Eastern Daylight Time] \* SVR:USPTO-EFXRF-1/1 \* DNIS:8729306 \* CSID: \* DURATION (mm-ss):22-16

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Application No.	Filing Date	Examiner		Group Art Unit
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US\$N 10/781,251

Attorney Docket No. 2003-0105-02
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I hereby certify that this paper or fee is being sent via facsimile ((703) 872-9306) services under 37 C.F.R. 1.8 on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.

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JUN 1 4 2004

In re Application of:

Palash P. Das, et al.

Serial No.: 10/781,251

Filing Date: February 18, 2004

Title: VERY HIGH ENERGY, HIGH

STABILITY GAS DISCHARGE LASER SURFACE TREATMENT SYSTEM Examiner: Unassigned

Group Art Unit: Unassigned

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## Dear Sir:

In accordance with 37 C.F.R. § 1.97 and § 1.98, applicants submit for consideration in the above-identified application the attached Form PTO-1449. The Information Disclosure Statement submitted herewith is being filed before the mailing date of the first Office Action on the merits. Copies of the cited references are not provided pursuant to the USPTO waiving the requirement of submitting patent copies for applications filed after June 30, 2003, however Items AZ through BD are provided herewith.

It is respectfully requested that the Examiner indicate consideration of the cited references by returning a copy of the attached form PTO-1449 with initials or other appropriate marks.

PACE 3/43 \* RCVD AT 6/14/2004 3:02:32 PM [Eastern Daylight Time] \* SVR:USPTO-EFXRF-1/1 \* DMIS:8729306 \* CSID: \* DURATION (mm-ss):22-16

USSN 10/781,251 Attorney Docket No. 2003-0105-02

This Information Disclosure Statement under 37 C.F.R. § 1.97 is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Accordingly, no fee is believed to be due. The Commissioner is hereby authorized to charge any fees, or to credit any overpayment to Deposit Account No. 03-4060.

Respectful submitted

William Cray; Reg. No. 27,627

June 1., 2004
Cymer, Inc.
Legal Department - MS/4-2C
17075 Thoramint Court
San Diego, California 92127-1712

Telephone: 858-385-7185 Facsimile: 858-385-6025

PAGE 4143 \* RCVD AT 6144/2004 3:02:32 PM [Eastern Daylight Time] \* SVR:USPTO-EFXRF-111 \* DNIS:8729306 \* CSID: \* DURATION (mm-55):22-16

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)				
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	A	4,223,279	9/16/80	Bradford, Jr., et al.	331	94.5			
<u> </u>	В	4,455,658	6/19/84	Sutter, et al.	372	38			
	С	4,618,759	10/21/86	Muller, et al.	219	121			
	a	4,959,840	9/25/90	Robert Akins, et al.	372	57	-		
	E	5,023,884	6/11/91	Robert Akins, et al.	372	57			
·	F	5,025,445	6/18/91	Anderson, et al.	372	20		-	
	G	5,025,446	6/18/91	Dirk J. Kuizenga	372	21			
	н	5,189,678	2/23/93	Ball, et al.	372	28			
	I	5,313,481	5/17/94	Cook, et al.	372	37		•	
	J	5,315,611	5/24/94	Ball, et al.	372	56			
	K	5,359,620	10/25/94	Robert Akins	372	58			
	L	5,448,580	9/5/95	Birx, et al.	372	38			
·	M	5,471,965	12/5/95	Davorin D. Kapich	123	565	_		
	N	5,852,621	12/22/98	Richard L. Sandstrom	372	25			
	0	5,863,017	1/26/99	Larson, et al.	248	176.1		_	
	P	5,953,360	9/14/99	Vitruk, et al.	372	87			
	Q	5,978,394	11/2/99	Newman, et al.	372	32			
	R	5,991,324	11/23/99	Knowles, et al.	372	57	<del></del>		
	S	6,005,879	12/21/99	Sandstrom, et al.	372	25		-	
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			Fore	eign Patent Documents			···	<u> </u>	
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	V	6,028,880	2/22/00	Carlesi, et al.	372	58			
	W	6,067,306	5/23/00	Sandstrom, et al.	372	38			
	X	6,067,311	5/23/00	Morton, et al.	372	57		•	
	Y	6,094,448	7/25/00	Fomenkov, et al.	372	102	<b>†</b>		
	Z	6,104,735	8/15/00	R. Kyle Webb	372	37			
	AA	6,128,323	10/3/00	Myers, et al.	372	38	<del> </del>		
	AB	6,143,661	11/7/00	Kousai, et al.	438	689			
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	AD	6,164,116	12/26/00	Rice, et al.	73	1.72	<del>                                     </del>		
	ĀE	6,192,064	2/20/01	Algots, et al.	372	99			
	AF	6,208,674	3/27/01	Webb, et al.	372	57			
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	AH	6,212,211	4/3/01	Azzola, et al.	372	33			
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	AJ	6,240,117	5/29/01	Gong, et al.	372	58			
	AK	6,317,447	11/13/01	Partlo, et al.	372	57			
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	AM	6,414,979	7/2/02	Ujazdowski, et al.	372	87			
	AN	6,477,193	11/5/02	Oliver, et al.	372	58			
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	AP	6,567,450	5/20/03	Myers, et al.	372	55	· · · · · · · · · · · · · · · · · · ·		
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